

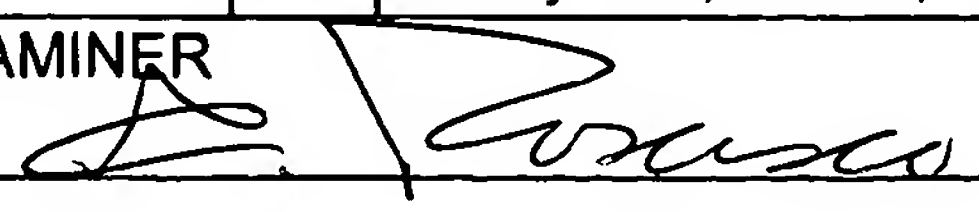
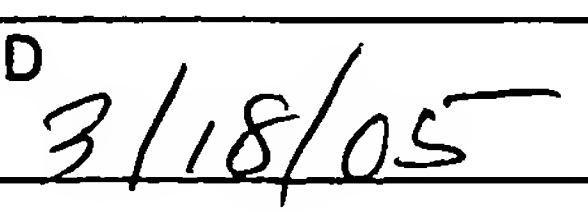


FORM PTO-1449 (SUBSTITUTE) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))				Attorney Docket No.: P2002,0645 Appl. No.: Applicant: FRANK-MICHAEL KAMM ET AL. Filing Date: August 1, 2003 Group Art Unit:			
EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A						
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FOREIGN PATENT DOCUMENT							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
	J	1 065 532 A2	1/3/01	Europe			
	K						
	L						
	M						
	N						
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
		Morita, M. et al.: "Native Oxide Growth on Silicon Surface in Wet Ambient", Extended Abstract of the 22 nd Conference on Solid State Devices and Materials, 1990, pp. 1063-1066					
		Yasaka, T. et al.: "Layer-By-Layer Oxidation of Silicon", Materials Research Society Proc., Vol. 222, 1991, pp. 225-230					
EXAMINER				DATE CONSIDERED			
				 3/18/05			

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FOREIGN PATENT DOCUMENT

	J	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES	NO
	J							
	K							
	L							
	M							
	N							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	Morita, M. et al.: "Control Factor of Native Oxide Growth on Silicon Surface in Air or in Ultrapure Water", Appl. Phys. Lett. 55 (6), American Institute of Physics, August 7, 1989, pp. 562-564

EXAMINER 	DATE CONSIDERED <div style="text-align: right; font-size: 1.2em;">3/18/05</div>